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## APPLICANTS

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## \*\* CONTINUING DATA \*\*\*\*\*

This application is a DIV of 09/803,044 03/12/2001 PAT 6,815,162

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 06/30/2004

Foreign Priority claimed	<input type="checkbox"/> yes <input type="checkbox"/> no	STATE OR	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	COUNTRY	DRAWING	CLAIMS	CLAIMS
Verified and Acknowledged	<i>Rabah Boukherroub</i> <i>David J. Lockwood</i> Examiner's Signature Initials	CANADA	12	33	2

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## TITLE

Passivation of porous semiconductors

<input type="checkbox"/> All Fees
<input type="checkbox"/> 1.16 Fees ( Filing )